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BIB DATA SHEET

CONFIRMATION NO. 3608

| SERIAL NUM | IBER FILING OF | | | 371(c) CLASS | | GROUP ART UNIT | | UNIT | ATTORNEY DOCKET | |
|---|--|-----|--------------------|--------------|------------------|--------------------|---------------------------------------|-----------------|-----------------|-----------------------|
| 10/581,60 | | | _ | | 438 | 2812 | | 292134US26PCT | | |
| | | RUL | E | | | | | | | |
| APPLICANTS Masaru Sasaki, Hyogo, JAPAN; Shinji Ide, Hyogo, JAPAN; Shigenori Ozaki, Hyogo, JAPAN; | | | | | | | | | | |
| ** CONTINUING DATA *********************************** | | | | | | | | | | |
| ** FOREIGN APPLICATIONS ************************************ | | | | | | | | | | |
| ** IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 02/07/2007 | | | | | | | | | | |
| Foreign Priority claimed Yes No 35 USC 119(a-d) conditions met YYes No | | | ☐ Met af Allowa | ter .nce | STATE OR COUNTRY | SHEETS DRAWINGS | | TOTAL CLAIMS | | INDEPENDENT CLAIMS |
| Verified and /SEAHVOSH J NIKMANESH/ Acknowledged Examiner's Signature | | | SJN Initials | | JAPAN | 7 | | 21 | | 2 |
| ADDRESS | | | | | | | | | | |
| OBLON, SPIVAK, MCCLELLAND MAIER & NEUSTADT, L.L.P. 1940 DUKE STREET ALEXANDRIA, VA 22314 UNITED STATES | | | | | | | | | | |
| TITLE | | | | | | | | | | |
| Method of cleaning semiconductor substrate conductive layer surface | | | | | | | | | | |
| | EFFC: Authority has been given in Daney | | | | | | ☐ All Fees | | | |
| | | | | | | | ☐ 1.16 Fees (Filing) | | | |
| FILING FEE RECEIVED | FEES: Authority has been given in Paper No to charge/credit DEPOSIT ACCOUNT | | | | | NT | ☐ 1.17 Fees (Processing Ext. of time) | | | |
| 950 | No for following: | | | | | | ☐ 1.18 Fees (Issue) | | | |
| | | | | | | | Other | | | |
| | | | | | | ☐ Credit | | | | |
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